Electronic Patent Application Fee Transmittal							
Application Number:	100	10602468					
Filing Date:	23-	23-Jun-2003					
Title of Invention:		Metalorganic chemical vapor deposition (MOCVD) process and apparatus to produce multi-layer high-temperature superconducting (HTS) coated tape					
First Named Inventor/Applicant Name:	Vei	Venkat Selvamanickam					
Filer:	Da	David A. Schell					
Attorney Docket Number:	10	1014-SP156-US					
Filed as Large Entity							
Utility under 35 USC 111(a) Filing Fees							
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Filing a brief in support of an appeal		1402	1	510	510		
Post-Allowance-and-Post-Issuance:							
Extension-of-Time:							

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
	Total in USD (\$)			510